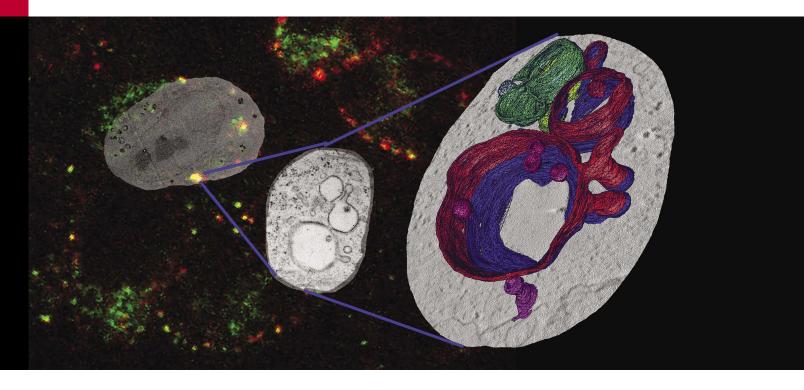
#### Living up to Life





# Introducing the cryoCLEM Workflow

CLEM combines light microscopy with electron microscopy. cryoCLEM is a key technique for deciphering the complexity of cells virtually in their native state. Leica Microsystems makes cryoCLEM easy with our new workflow. Learn how valuable complementary and unique information can be achieved using dual examination. See it at booth #902.

Please join us for the following vendor tutorials on Tuesday, August 5, 2014 at 5:45 pm:

- Leica Cryo-CLEM Workflow Solution
- Introduction to Confocal Microscopy for Surface-Metrology Applications

Visit booth #902 at M&M 2014



### Your Image Starts Here!

# EXPERIENCE THE LATEST INTOUCHSCOPE RESEARCH GRADE SEM



### IT300LV

- Multi-touch interface
- High throughput microanalysis
- High vacuum to extended pressure
- Intuitive operation

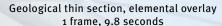




Smart analytical port geometries

Unique in-chamber stage







Dual EDS, lead/tin wave solder powder



Silica beads, low kV SE image



